



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

ATTY.'S DOCKET: NREL/96-48

#5/a  
H. J. J. J.  
1-13-99

Applicant: Timothy A. Gessert )  
Serial No.: 08/937,721 ) Group Art: 1741  
Filing Date: September 25, 1997 ) Examiner: S. Mulburi  
Title: ION-BEAM TREATMENT TO )  
PREPARE SURFACES OF )  
P-CdTe FILMS )

AMENDMENT UNDER 37 CFR §1.115

Honorable Commissioner of Patents and Trademarks  
Washington, D.C. 20231

Sir:

In reply to the Official Action of October 15, 1998,  
rejecting the claims in the above-identified patent application,  
applicant respectfully request reconsideration, based upon the  
amendments hereinafter set forth.

IN THE CLAIMS

Please cancel claim 3 without prejudice.

RECEIVED  
DEC 24 1998  
GROUP 1700

1. (Amended) A [method] dry process [of] for making a low-

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